

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 22, 2024

IGI Report Number

LG660490061

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

SQUARE EMERALD CUT

Measurements

8.84 X 8.83 X 5.67 MM

GRADING RESULTS

Carat Weight

4.01 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

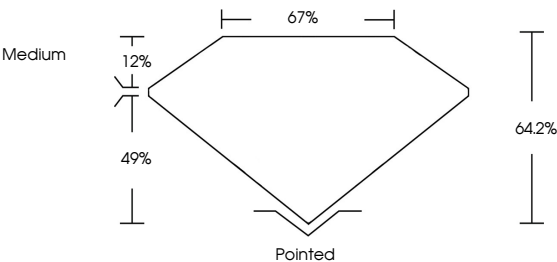
Inscription(s)

 LG660490061

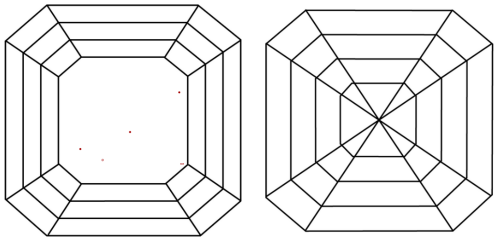
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR


D E F G H I J Faint Very Light Light

CLARITY

IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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
Symmetry

EXCELLENT

Fluorescence

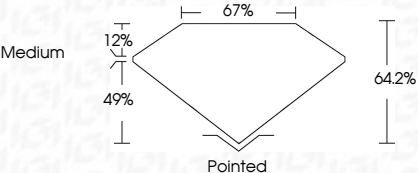
NONE



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PROPORTIONS





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SQUARE EMERALD CUT

8.84 X 8.83 X 5.67 MM

4.01 CARATS

E

VS 1

64.2%

67%


Medium

Pointed

EXCELLENT

EXCELLENT

NONE

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